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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10080540	02/25/2002	216	63	1725	

****APPLICANTS:** Mizumura Michinobu; Fukuyama Ryooji; Ohmoto Yutaka; Watanabe Katsuya;

****CONTINUING DATA VERIFIED:**

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**** FOREIGN APPLICATIONS VERIFIED:**

JAPAN 2001-286052 09/20/2001

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed

☒ yes ☐ no

35 USC 119 conditions met

☒ yes ☐ no

Verified and Acknowledged Examiners's initials

[Signature]

ATTORNEY DOCKET NO

500.41254X00

TITLE : Etching method of organic insulating film

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Applicati n Examiner	
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